

<b>Notice of Allowability</b>	Application No.	Applicant(s)	
	10/602,836	CHANG, MEI YIN	
	Examiner	Art Unit	
	Christopher D Prone	3738	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1.  This communication is responsive to the application filed on 6/24/03.
2.  The allowed claim(s) is/are 1-6,8-10 and 12.
3.  The drawings filed on \_\_\_\_\_ are accepted by the Examiner.
4.  Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a)  All
  - b)  Some\*
  - c)  None
 of the:
  1.  Certified copies of the priority documents have been received.
  2.  Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
  3.  Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

\* Certified copies not received: \_\_\_\_\_.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  
**THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.**

5.  A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
6.  CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.
  - (a)  including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached
    - 1)  hereto or 2)  to Paper No./Mail Date \_\_\_\_\_.
  - (b)  including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date 1/22/07.
- Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
7.  DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

#### Attachment(s)

1.  Notice of References Cited (PTO-892)
2.  Notice of Draftsperson's Patent Drawing Review ( PTO-948)
3.  Information Disclosure Statements (PTO-1449 or PTO/SB/08),  
Paper No./Mail Date \_\_\_\_\_
4.  Examiner's Comment Regarding Requirement for Deposit  
of Biological Material
5.  Notice of Informal Patent Application (PTO-152)
6.  Interview Summary (PTO-413),  
Paper No./Mail Date 1/22/07.
7.  Examiner's Amendment/Comment
8.  Examiner's Statement of Reasons for Allowance
9.  Other \_\_\_\_\_.

  
CDP

### **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Clement Chang on 01/22/07.

The application has been amended as follows:

Claims 7 and 11 are cancelled.

Claims 1, 3, and 9, have been replaced with:

1. A canister rack system for a microderm abrasion machine comprising:

a canister rack having a base with bores through the base forming conduits for crystal passage through the canister rack, to a microderm abrasion machine;

a pair of canisters mountable upon the canister rack, including a supply canister and a storage canister, wherein the supply canister has a feeding conduit for the exit of crystal from the supply canister, wherein the storage canister has a return conduit and a filtered conduit;

wherein the canister rack bores forming conduits are formed at the base which is the interface between the canister rack and pair of canisters, so that the conduits from the storage canister and supply canister meet with their respective conduits formed in the canister rack to form an airtight seal;

horizontal locking pins protruding from one of either the canister rack or the canisters locking into a pair of horizontal slots formed in the other of the canister rack or the canisters

a vertical locking pin protruding from the base of the canister rack locking into a slot formed in each canister;

a latch attaching each canister to the canister rack.

3. The canister rack system of claim 1, wherein the horizontal locking pins protrude from the canister rack and lock into a slot formed in the canisters.

9. A canister rack system for a microderm abrasion machine comprising:

a canister rack having a base with bores through the base forming conduits for crystal passage through the canister rack, to a microderm abrasion machine;

a pair of canisters detachably mounted to the canister rack, including a supply canister and a storage canister, wherein the supply canister has a feeding conduit for the exit of crystal from the supply canister, wherein the storage canister has a return conduit and a filtered conduit;

wherein canister rack bores form conduits at the base;

a locking mechanism to attach each canister to the canister rack comprising horizontal locking pins that protrude from the canister rack and lock into a slot formed in each of the canisters.

In regards to the figures the examiner has attached a slightly modified version of the figures. They are a cleaned up version of the figures received on 10/13/06. The

applicant is required to resubmit a clean version of these drawings, with any other corrections.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Christopher D. Prone whose telephone number is (571) 272-6085. The examiner can normally be reached on Monday Through Fri 8:30 to 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Corrine McDermott can be reached on (571) 272-4754. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Christopher D Prone  
Examiner  
Art Unit 3738

CDP

  
CORRINE McDERMOTT  
SUPERVISORY PATENT EXAMINER  
TECHNOLOGY CENTER 3700

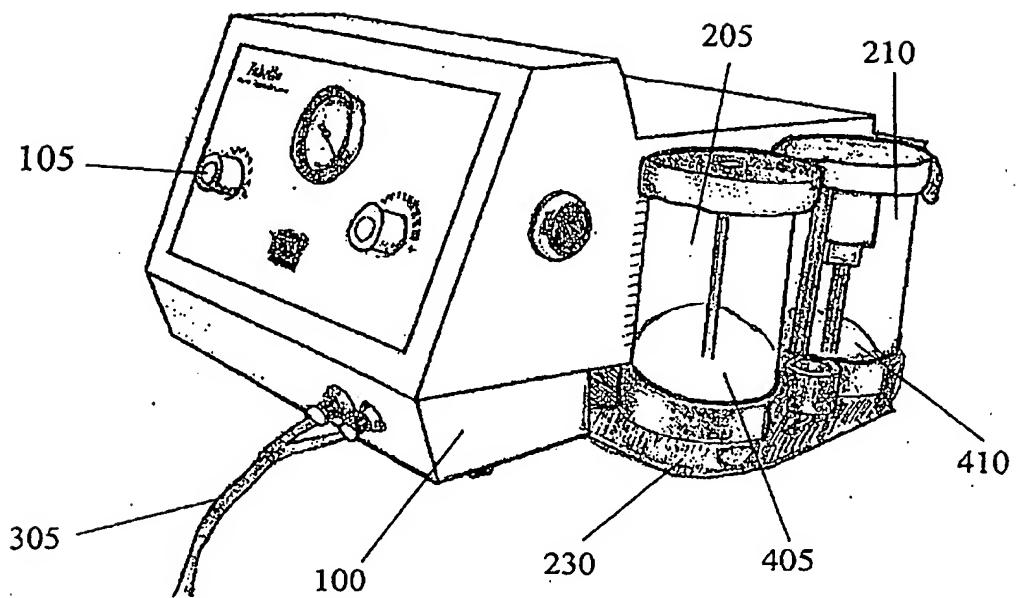


Fig. 1

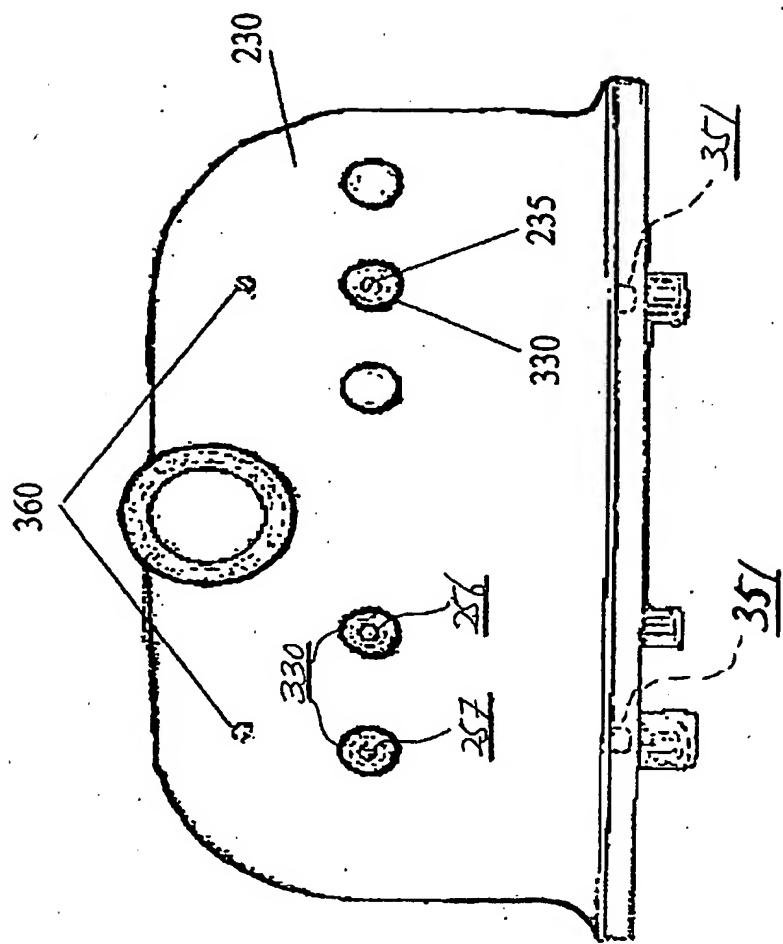


Fig.2

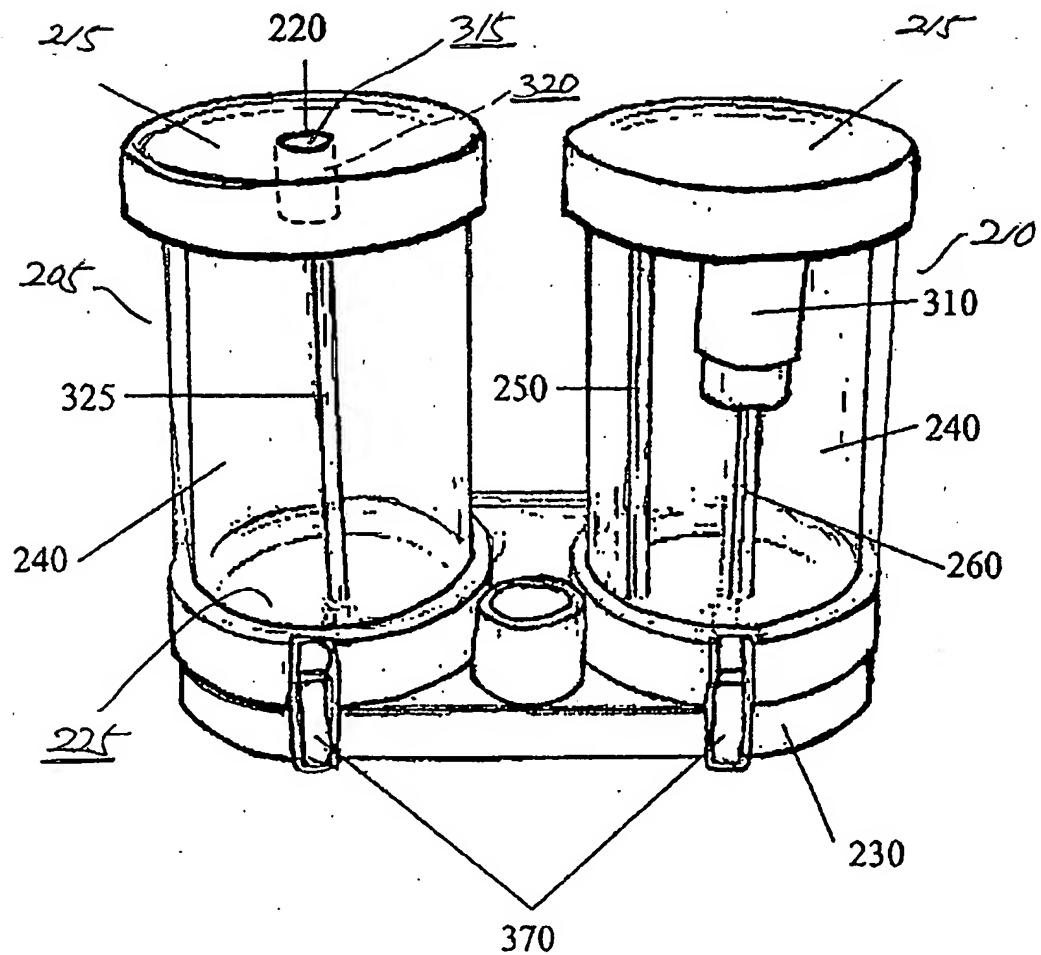


Fig.3

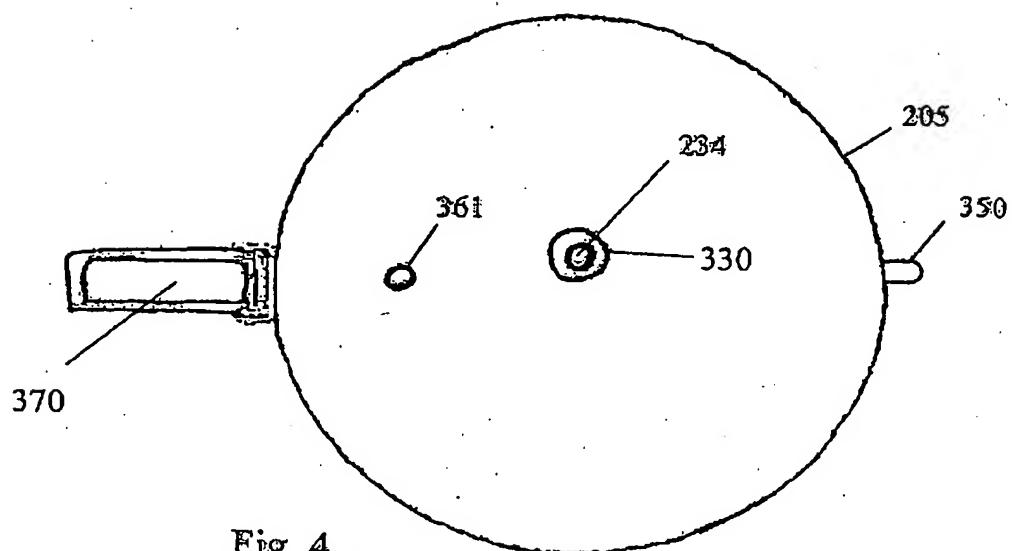


Fig. 4

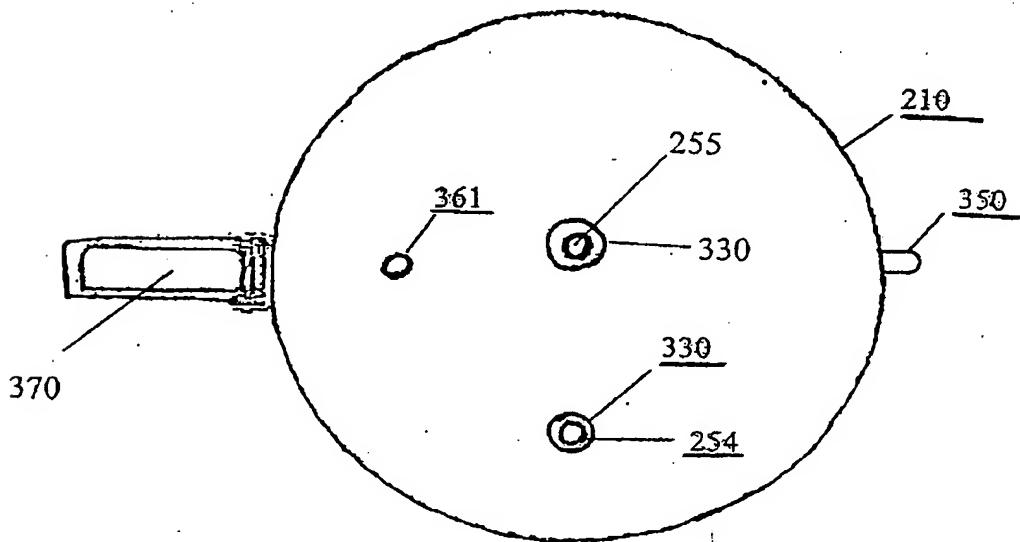


Fig. 5